

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mitsutoshi MIYASAKA

Application No.: New Rule 53(b) Continuation of
U.S. Application No. 09/373,982

Filed: June 21, 2001

Docket No.: 036654 D

For: FABRICATION METHOD FOR A THIN FILM SEMICONDUCTOR
DEVICE, THE THIN FILM SEMICONDUCTOR DEVICE ITSELF,
LIQUID CRYSTAL DISPLAY, AND ELECTRONIC DEVICE

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

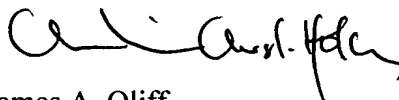
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.



- ☒ 2. The references were cited by or submitted to the Office in parent application No. 09/373,982, filed August 19, 1999, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,



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